



**ELECTRONIC COPY**

LG762547482  
Report verification at igi.org



January 6, 2026  
IGI Report Number **LG762547482**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **10.64 X 7.09 X 4.63 MM**  
**GRADING RESULTS**  
Carat Weight **3.00 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**

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**GRADING RESULTS**

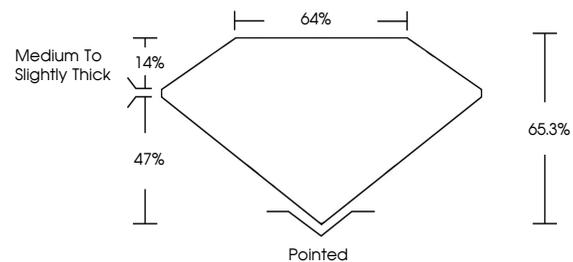
Carat Weight **3.00 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG762547482**

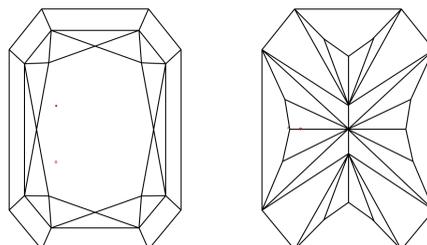
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

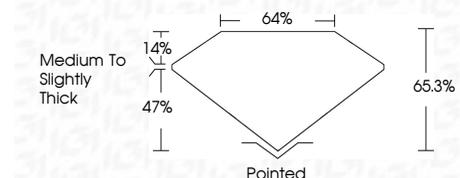
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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**CUT CORNERED RECT. MODIFIED BRILLIANT**  
**3.00 CARATS**  
**E**  
**VS 1**  
**65.3%**  
**47%**  
**Medium to Slightly Thick**  
**Pointed**  
**EXCELLENT**  
**EXCELLENT**  
**NONE**  
**IGI LG762547482**

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